



AP/1765
IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Confirmation No.: 1242

Masaro TAMATSUKA

Group Art Unit: 1765

Application No.: 09/868,901

Examiner: Robert M. KUNEMUND

Filed: July 9, 2001

Attorney Dkt. No.: 107242-00019

For: SILICON SINGLE CRYSTAL WAFER AND MANUFACTURING PROCESS
THEREFOR

RESPONSE TO FINAL REJECTION UNDER 37 C.F.R. § 1.116

MAIL STOP AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Date: June 7, 2004

Sir:

This paper is filed in reply to the Office Action dated April 2, 2004.